Docket No. 247409US26 MAR 2 2 2000 E IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Shosuke ENDOH, et al.

SERIAL NO: 10/751,898

GAU:

1763

FILED:

January 7, 2004

EXAMINER: MACARTHUR, S.

FOR:

PLASMA PROCESSING APPARATUS AND FOCUS RING

REQUEST FOR EXTENSION OF TIME UNDER 37 C.F.R. 1.136

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

It 1	s hereby requested that a three month extension of time be granted to March 22, 2007 for
	filing a response to the Official Action dated:
	responding to the requirements in the Notice of Allowability dated:
	filing the Formal Drawings. The Issue Fee due has been timely filed.
	responding to the Notice to File Missing Parts of Application dated:
	filing a RCE. A timely response to the final rejection, dated September 22, 2006, is being filed herewith.
	filing an Appeal Brief. A Notice of Appeal was filed on:
	Applicant claims small entity status. See 37 CFR 1.27. Therefore, the fee amount shown below is reduced by one-half.
The required fee of \$1,020.00 is enclosed herewith by credit card payment and any further charges may be made	

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,

MAIER & NEUSTADT, P.C.

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